

PATENT
Docket No 150.00880107IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Derderian et al.) Group Art Unit: 2818
Serial No.: 10/042,025) Examiner: Dang, P.
Confirmation No.: 5745)
Filed: 25 October 2001)

For: METHODS FOR FORMING ROUGH RUTHENIUM-CONTAINING LAYERS
AND STRUCTURES METHODS USING SAME

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Restriction Requirement mailed 11 September 2002, Applicants elect, without traverse, Group I (claims 30-40), drawn to conductive structures. Applicants' Representatives reserve the right to pursue examination of the non-elected claims in continuation or divisional applications.

The Examiner is invited to contact Applicants' Representatives, at the below-listed telephone number, if there are any questions regarding this Response or if prosecution of this application may be assisted thereby.

CERTIFICATE UNDER 37 C.F.R. § 1.8

The undersigned hereby certifies that this paper is being transmitted by facsimile in accordance with 37 C.F.R. § 1.6(a) to the Patent and Trademark Office, addressed to Assistant Commissioner for Patents, Washington, D.C. 20231, on the 25 day of September, 2002, at 10:35 AM (Central Time).

Sam E. Olsen
Name: Sam E. Olsen

25 Sept 2002
Date

Respectfully submitted for
Micon Technology, Inc.

By
Mueiting, Raasch & Gebhardt, P.A.
P.O. Box 581415
Minneapolis, MN 55458-1415
Phone: (612)305-1220
Facsimile: (612)305-1228
Customer Number 26813



26813

PATENT AND TRADEMARK OFFICE

By

Mark J. Gebhardt
Mark J. Gebhardt
Reg. No. 35,518
Direct Dial (612)305-1216